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## \*BIBDATASHEET\*

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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 08/965,892 11/07/1997 PAT 6,113,733

*CME*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 8-296592 11/08/1996  
JAPAN 8-350612 12/27/1996  
JAPAN 9-015382 01/29/1997  
JAPAN 9-189841 07/15/1997*CME*

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35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 29	CLAIMS 103	CLAIMS 7
Verified and Acknowledged	<i>C. Everhart</i> <i>CME</i> Examiner's Signature Initials				

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## TITLE

Apparatus and method for optical evaluation, apparatus and method for manufacturing semiconductor device, method of controlling apparatus for manufacturing semiconductor device, and semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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